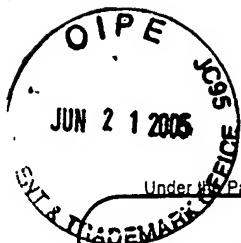


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TRANSMITTAL FORM

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Total Number of Pages in This Submission

Application Number

10/720,372

Filing Date

11/24/2003

First Named Inventor

Ghiron

Art Unit

2874

Examiner Name

Jerry T. Rahl

Attorney Docket Number

SIO-0107

ENCLOSURES (Check all that apply)

☐

Fee Transmittal Form

☐

Fee Attached

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Amendment/Reply

☐

After Final

☐

Affidavits/declaration(s)

☐

Extension of Time Request

☐

Express Abandonment Request

☐

Information Disclosure Statement

☐

Certified Copy of Priority Document(s)

☐Reply to Missing Parts/
Incomplete Application☐Reply to Missing Parts
under 37 CFR 1.52 or 1.53☐

Drawing(s)

☐

Licensing-related Papers

☐

Petition

☐Petition to Convert to a
Provisional Application☐

Power of Attorney, Revocation

☐

Change of Correspondence Address

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Terminal Disclaimer

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Remarks

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After Allowance Communication to TC

☐Appeal Communication to Board
of Appeals and Interferences☐Appeal Communication to TC
(Appeal Notice, Brief, Reply Brief)☐

Proprietary Information

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Status Letter

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SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm Name

Wendy W. Koba, Esq.

Signature

Wendy W. Koba

Printed name

Wendy W. Koba

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Patent Application for:

Applicants: Margaret Ghiron et al.

Atty. No: SIO-0107

Title: Beam Shaping and Practical Methods
of Reducing Loss Associated with Mating
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Waveguides

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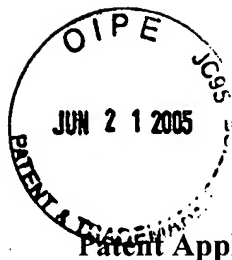
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IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

Patent Application

Inventor(s) Margaret Ghiron et al.

Case SIO-0107

Conf. No. 4738

Serial No. 10/720,372

Group Art Unit 2874

Filing Date November 24, 2003

Examiner Jerry T. Rahl

Title Beam Shaping and Practical Methods of Reducing Loss Associated
With Mating External Sources and Optics to Thin Silicon Waveguides

COMMISSIONER OF PATENTS
WASHINGTON, D.C. 20231

SIR:

AMENDMENT

In response to the *Notice of Drawing Inconsistency with Specification* dated May 23, 2005 (application Paper No. not shown), please amend the above-identified application as follows: